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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
09/839,028	04/19/2001	Antonius Henricus Elisabeth Breuls	750034.427C2	2396	
500	7590 11/12/2003		EXAM	EXAMINER	
SEED INTELLECTUAL PROPERTY LAW GROUP PLLC			HASSANZADEH, PARVIZ		
701 FIFTH AV SUITE 6300	VE		ART UNIT	PAPER NUMBER	
SEATTLE, W	'A 98104-7092		1763	_	

DATE MAILED: 11/12/2003

Please find below and/or attached an Office communication concerning this application or proceeding.

in cupale and al	Application No.	Applicant(s)	Applicant(s)	
NIC Supplemental Notice of Allowability	09/839,028	BREULS ET AL.		
Notice of Allowability	Examiner	Art Unit		
	Parviz Hassanzadeh	1763		
The MAILING DATE of this communication at All claims being allowable, PROSECUTION ON THE MERITS herewith (or previously mailed), a Notice of Allowance (PTOLNOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT of the Office or upon petition by the applicant. See 37 CFR 1. 1. ★ This communication is responsive to 8/14/03. 2. ★ The allowed claim(s) is/are 1,2 and 7. 3. ★ The drawings filed on 19 April 2001 are accepted by the Acknowledgment is made of a claim for foreign priority a) ★ All b) ★ Some* c) ★ None of the: 1. ★ Certified copies of the priority documents here in the priority documents in the priority document is needed.	ppears on the cover sheet with IS (OR REMAINS) CLOSED in 185) or other appropriate communt RIGHTS. This application is su 313 and MPEP 1308. e Examiner. under 35 U.S.C. § 119(a)-(d) or (lave been received. ave been received in Application documents have been received.	the correspondence at this application. If not incidential in the mailed in displaying the mailed in	luded ue course. THIS ssue at the initiative	
 Acknowledgment is made of a claim for domestic priorit (a)	al application has been received. y under 35 U.S.C. §§ 120 and/or " of this communication to file a r of this application. THIS THRE	121. eply complying with the re E-MONTH PERIOD IS NO	OT EXTENDABLE.	
 7. A SUBSTITUTE OATH OR DECLARATION must be su INFORMAL PATENT APPLICATION (PTO-152) which gives result of the submitted. 8. CORRECTED DRAWINGS must be submitted. (a) including changes required by the Notice of Drafts; 1) hereto or 2) to Paper No (b) including changes required by the proposed drawing including changes required by the attached Examing light of the submitted including changes required by the attached Examing light of the submitted including such as the application number (see 37 CFI each sheet. 	eason(s) why the oath or declara person's Patent Drawing Review ng correction filed, which ner's Amendment / Comment or i	tion is deficient. (PTO-948) attached has been approved by the office action of Papharawings in the front (not	e Examiner. er No the back) of	
9. DEPOSIT OF and/or INFORMATION about the de attached Examiner's comment regarding REQUIREMENT FOR Attachment(s)	POSIT OF BIOLOGICAL MATER R THE DEPOSIT OF BIOLOGICA	RIAL must be submitted AL MATERIAL.	!. Note the	
 Notice of References Cited (PTO-892) Dotice of Draftperson's Patent Drawing Review (PTO-948) Information Disclosure Statements (PTO-1449), Paper No.) 4☐ Interview 5 6☐ Examiner's	nformal Patent Application Summary (PTO-413), Pap S Amendment/Comment		
7 Examiner's Comment Regarding Requirement for Deposit of Biological Material	8⊠ Examiner's 9⊡ Other	Statement of Reasons for	or Allowance	

Application/Control Number: 09/839,028

Art Unit: 1763

DETAILED ACTION

Priority

Receipt is acknowledged of papers submitted under 35 U.S.C. 119(a)-(d), which papers have been placed of record in the file.

Allowable Subject Matter

Claims 1, 2 and 7 allowed.

The following is an examiner's statement of reasons for allowance:

A chemical vapor deposition (CVD) apparatus comprising an annular microwave cavity including an outer and an inner cylindrical walls wherein the inner wall having a slit extending in a full circle around the cylindrical axis, and an elongated microwave guide having a longitudinal axis that is substantially perpendicular to the cylindrical axis of the cavity and does not intercept the slit, and wherein the width (W) of the slit is equal or less than one tenth of the vacuum wavelength (λ) of the microwave radiation, that is, $W \leq \lambda$, both measured in a direction parallel to the cylindrical axis.

The relatively narrow slit width enhances the electric field strength in the microwave generated plasma.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

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Any inquiry concerning this communication or earlier communications from the examiner should be directed to Parviz Hassanzadeh whose telephone number is (703)308-2050. The examiner can normally be reached on Tuesday-Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Gregory Mills can be reached on (703)308-1633. The fax phone number for the organization where this application or proceeding is assigned is (703) 872-9306.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703)308-0661.

P. Hassanzadeh Parviz Hassanzadeh Primary Examiner Art Unit 1763

November 7, 2003